# EXHIBIT B

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Tamaki et al.       (45) **Date of Patent:**     **Sep. 21, 2004**

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(54) **SEMICONDUCTOR INTEGRATED CIRCUIT DEVICE AND METHOD FOR FABRICATING THE SAME**

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(58) **Field of Search** ........................ 257/41, 2, 202–211, 257/390, 401

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(57)       **ABSTRACT**

Variations in the size of a linear pattern resulting from difference in mask pattern layout are prevented by setting the perimeter of the linear pattern per unit area in a specified range irrespective of the type of a semiconductor integrated circuit device or by adjusting a process condition in accordance with type-to-type difference in the perimeter of the linear pattern per unit area.
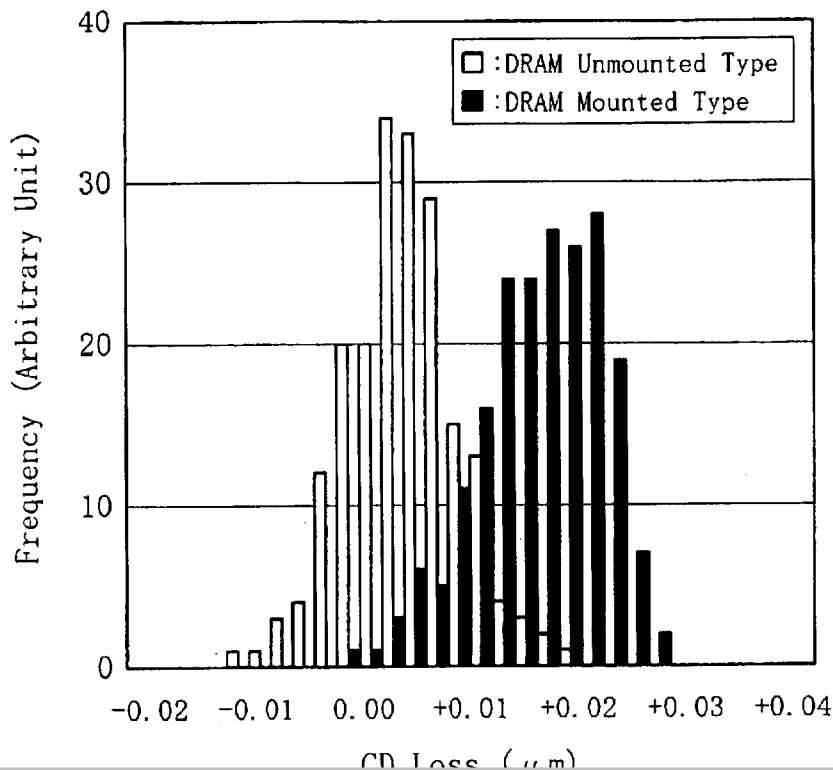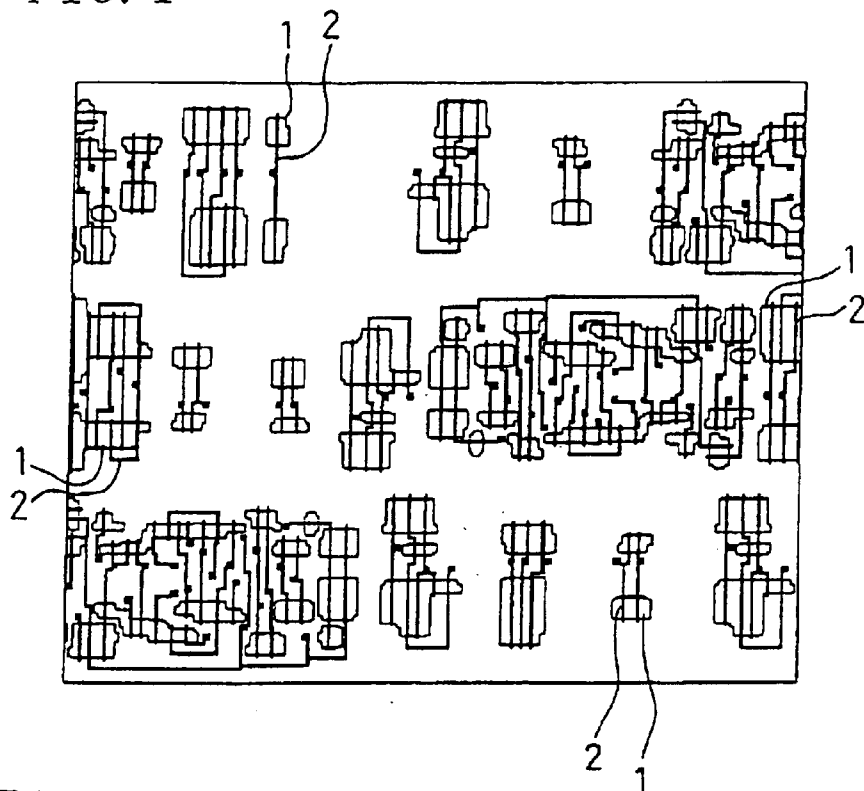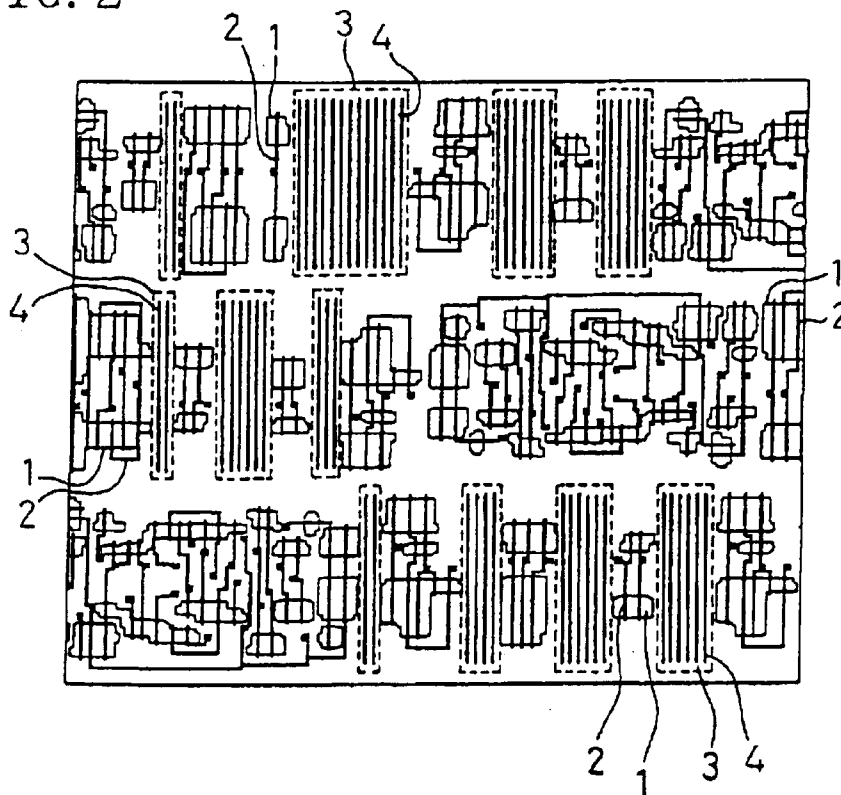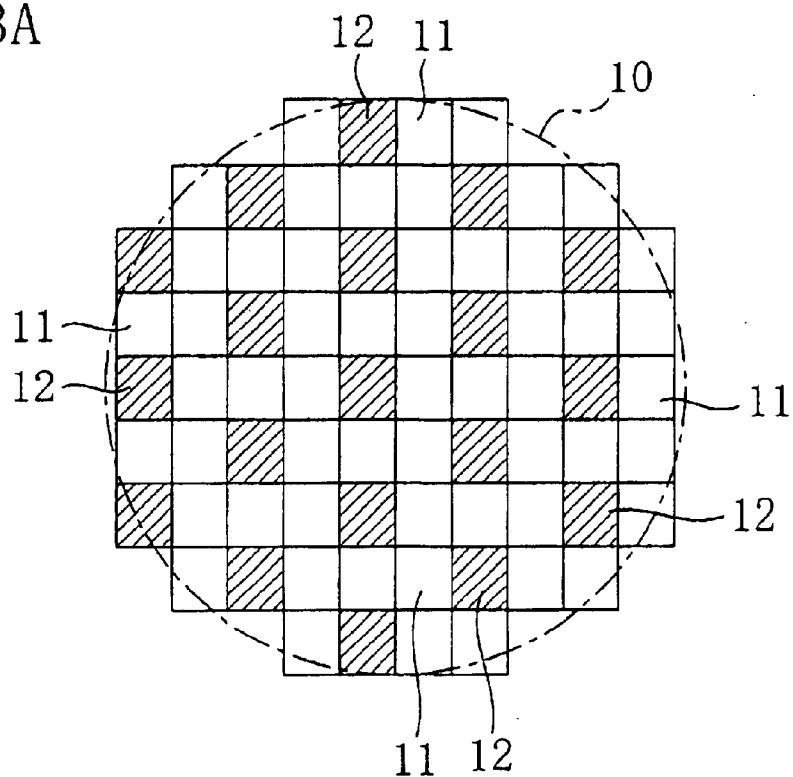
**6 Claims, 9 Drawing Sheets**
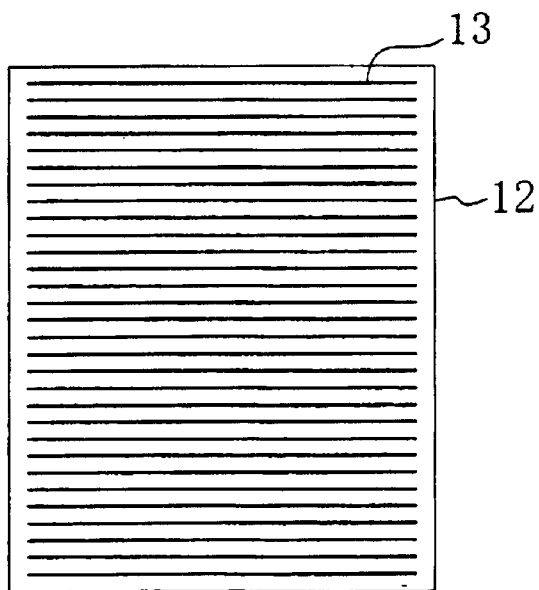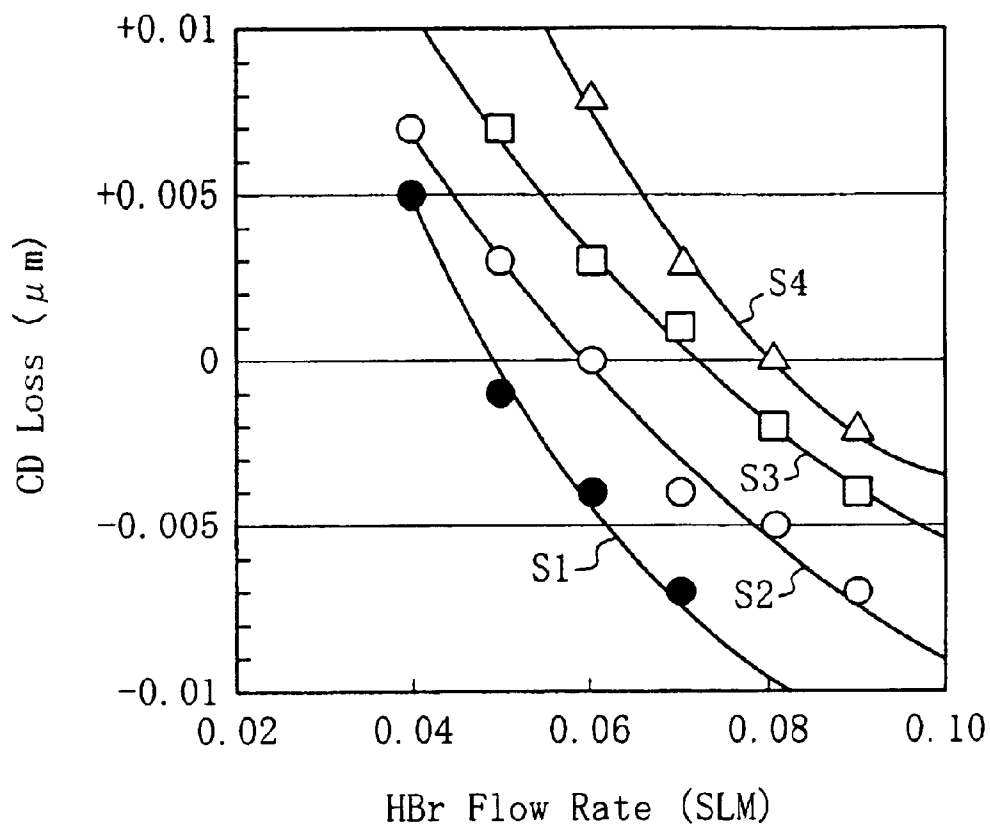
FIG. 1



FIG. 2

FIG. 3A



FIG. 3B

FIG. 4

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